



Dkt. 2271/71521

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

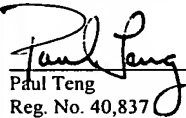
Application of: Takuro SEKIYA

Serial No.: 10/758,398

Date Filed: January 15, 2004

For: SOLUTION JET TYPE FABRICATION APPARATUS, METHOD, SOLUTION
CONTAINING FINE PARTICLES, WIRING PATTERN SUBSTRATE, DEVICE
SUBSTRATE

I hereby certify that this correspondence is being deposited this date with the U.S. Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.


Paul Teng
Reg. No. 40,837

November 9, 2005
Date

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT

Pursuant to the applicant's duty of disclosure, the information listed in the attached Form PTO-1449 is brought to the attention of the Examiner. Copies of the references cited in the annexed Form PTO-1449 are also provided.

It is respectfully requested that the information cited in annexed Form PTO-1449 be considered by the Examiner in connection with the above-identified patent application, and that such art be made of record in said application.

The references listed in the annexed Form PTO-1449 were cited in an August 30, 2005 Japanese Office Action in connection with Japanese Application No. 2003-009186 which corresponds to the above-identified application. A copy of the August 30, 2005 Japanese Office Action is enclosed. The remaining reference cited in the August 30, 2005 Japanese Office Action which is not listed on the annexed Form PTO-1449 was previously submitted to the USPTO with the Information Disclosure Statement filed on August 23, 2004 in connection with this

application.

The citation of the listed items is not a representation that they constitute a complete or exhaustive listing of the relevant art or that these items are prior art. The items listed are submitted in good faith, but are not intended to substitute for the Examiner's search. It is hoped, however, that in addition to apprising the Examiner of the particular items, they will assist in identifying fields of search and in making as full and complete a search as possible.


The filing of this Information Disclosure Statement is not an admission that the information cited herein is, or is considered to be, material to patentability as defined in 37 C.F.R. §1.56(b).

This Information Disclosure Statement is being filed pursuant to 37 C.F.R. §1.97(b)(3). To the best of Applicant's knowledge, this Information Disclosure Statement is being filed before the date of mailing of a first Office Action on the merits in connection with this case.

Alternatively, Applicant requests consideration of this Information Disclosure Statement under 37 C.F.R. §1.97(c)(1). Each item of information listed in the attached Form PTO-1449 was cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior hereto.

The Office is hereby authorized to charge any additional fees which may be required for consideration of this Information Disclosure Statement and to credit any overpayment to our Deposit Account No. 03-3125.

Respectfully submitted,



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Form PTO-1449 U.S. Department of Commerce Patent and Trademark Office INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)	Atty. Docket No. 2271/71521	Serial No. 10/758,398
	Applicant: Takuro SEKIYA	
	Filing Date: January 15, 2004	Group Art Unit:

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	JP 6 - 3 4 4 5 6 0	12-20-1994	Japan			Abstract	
	JP 9 - 3 2 0 3 6 3	12-12-1997	Japan			Abstract	
	JP 1 0 -2 0 4 3 5 0	8-4-1998	Japan			Abstract	
	JP 20 00 -2 5 1 6 7 4	9-14-2000	Japan			Abstract	
	JP 20 01 - 6 8 8 2 7	3-16-2001	Japan			Abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	August 30, 2005 Japanese Office Action in connection with Japanese Application No. 2003-009186 which corresponds to the above-identified application.

EXAMINER	DATE CONSIDERED
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*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.